

Notice of References Cited

Application/Control No.

09/991,973

Applicant(s)/Patent Under
Reexamination
KIM ET AL.

Examiner

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Art Unit

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,175,345	01-2003	Kuribayashi et al	345/76
	B	US-6,433,487	08-2002	Yamazaki	315/169
	C	US-6,114,183	09-2000	Hamada et al	438/29
	D	US-6,384,427	05-2002	Yamazaki et al	257/59
	E	US-6,424,326	07-2002	Yamazaki et al	345/77
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 11-8065	01-1999	Japan	Kuribayashi et al	
	O	JP 11-3048	01-1999	Japan	Kuribayashi et al	
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

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